

10694991_CLS
Most Frequently Occurring Classifications of Patents Returned
From A Search of 10694991 on June 16, 2004

Original Classifications

4 250/282
4 347/128
3 324/322
2 324/318

Cross-Reference Classifications

4 250/292
3 313/231.31
3 324/318
3 324/322
2 156/345.48
2 250/282
2 315/111.51
2 333/175
2 343/861

Combined Classifications

6 250/282
6 324/322
5 250/292
5 324/318
4 347/128
3 313/231.31
3 315/111.51
2 156/345.48
2 250/291
2 315/5.41
2 315/505
2 323/355
2 333/175
2 343/861

10694991_CLSTITLES

Titles of Most Frequently Occurring Classifications of Patents Returned

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6	250/282	(4 OR, 2 XR)
	Class 250 :	RADIANT ENERGY
	250/281	IONIC SEPARATION OR ANALYSIS
	250/282	.Methods
6	324/322	(3 OR, 3 XR)
	Class 324 :	ELECTRICITY: MEASURING AND TESTING
	324/300	PARTICLE PRECESSION RESONANCE
	324/318	.Spectrometer components
	324/322	..Electronic circuit elements
5	250/292	(1 OR, 4 XR)
	Class 250 :	RADIANT ENERGY
	250/281	IONIC SEPARATION OR ANALYSIS
	250/290	.Cyclically varying ion selecting field means
	250/292	..Laterally resonant ion path
5	324/318	(2 OR, 3 XR)
	Class 324 :	ELECTRICITY: MEASURING AND TESTING
	324/300	PARTICLE PRECESSION RESONANCE
	324/318	.Spectrometer components
4	347/128	(4 OR, 0 XR)
	Class 347 :	INCREMENTAL PRINTING OF SYMBOLIC INFORMATION
	347/111	ELECTRIC MARKING APPARATUS OR PROCESSES
	347/112	.Electrostatic
	347/120	..By information carrying flow of invisible charged particles
	347/128	...Including driving circuitry
3	313/231.31	(0 OR, 3 XR)
	Class 313 :	ELECTRIC LAMP AND DISCHARGE DEVICES
	313/231.01	FLUENT MATERIAL SUPPLY OR FLOW DIRECTING MEANS
	313/231.31	.Plasma
3	315/111.51	(1 OR, 2 XR)
	Class 315 :	ELECTRIC LAMP AND DISCHARGE DEVICES: SYSTEMS
	315/111.01	DISCHARGE DEVICE LOAD WITH FLUENT MATERIAL SUPPLY TO THE DISCHARGE SPACE

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 315/111.21 .Plasma generating
 315/111.41 ..With magnetic field
 315/111.51 ...Induction type

2 156/345.48 (0 OR, 2 XR)
 Class 156 : ADHESIVE BONDING AND MISCELLANEOUS CHEMICAL
 MANUFACTURE
 156/345.1 DIFFERENTIAL FLUID ETCHING APPARATUS
 156/345.48 .With radio frequency (rf) antenna or inductiv

e

coil gas energizing means

2 250/291 (1 OR, 1 XR)
 Class 250 : RADIANT ENERGY
 250/281 IONIC SEPARATION OR ANALYSIS
 250/290 .Cyclically varying ion selecting field means
 250/291 ..Circular ion path

2 315/5.41 (1 OR, 1 XR)
 Class 315 : ELECTRIC LAMP AND DISCHARGE DEVICES: SYSTEMS
 315/1 CATHODE RAY TUBE CIRCUITS
 315/3 .Combined cathode ray tube and circuit element
 structure
 315/4 ..Inductor or distributed parameter-type
 inductive structure
 315/5 ...Ray passes in or through a hollow
 distributed parameter device
 315/5.39Plural hollow devices
 315/5.41Accelerating or decelerating the ray
 between the hollow devices

2 315/505 (1 OR, 1 XR)
 Class 315 : ELECTRIC LAMP AND DISCHARGE DEVICES: SYSTEMS
 315/500 HIGH ENERGY PARTICLE ACCELERATOR TUBE
 315/501 .Magnetic field acceleration means
 315/505 ..Linear accelerator (Linac)

2 323/355 (1 OR, 1 XR)
 Class 323 : ELECTRICITY: POWER SUPPLY OR REGULATION
 SYSTEMS
 323/355 INCLUDING A TRANSFORMER OR AN INDUCTOR

2 333/175 (0 OR, 2 XR)
 Class 333 : WAVE TRANSMISSION LINES AND NETWORKS
 333/24R COUPLING NETWORKS

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333/167      .Frequency domain filters utilizing only lumped
d
              parameters
333/175      ..Resonant, discrete frequency selective type

2  343/861    (0 OR, 2 XR)
      Class 343 : COMMUNICATIONS: RADIO WAVE ANTENNAS
343/700R      ANTENNAS
343/850      .With coupling network or impedance in the
              leadin
343/860      ..Impedance matching network
343/861      ...Adjustable

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